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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2822**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tsuyoshi KANEKO et al.

Group Art Unit: 2822

Application No.: 10/092,777

Examiner: J. Vockrodt

Filed: March 8, 2002

Docket No.: 112181

For: METHOD OF FABRICATING SURFACE-EMISSION TYPE LIGHT-EMITTING  
DEVICE, SURFACE-EMITTING SEMICONDUCTOR LASER, METHOD OF  
FABRICATING THE SAME, OPTICAL MODULE AND OPTICAL TRANSMISSION  
DEVICE

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 1, 2004 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**